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U.S. Department of Commerce, Patent and Trademark Office	Attv Docket No.	Serial No.
	2000-0015-06	10/670,406
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s)
(Use several sheets if necessary)		Igor V. Fomenkov et al.
	Filing Date	Group
	September 24, 2003	2828

U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
Q	A	4,697,270	09/29/87	Galkowski	372	34	_____
	B	4,798,467	01/17/89	Wyeth et al.	356	349	_____
	C	4,817,101	03/28/89	Wyeth et al.	372	32	_____
	D	4,823,354	4/18/89	Znotins, et al.	372	57	_____
	E	4,881,231	11/14/89	Jain	372	32	_____
	F	4,883,352	11/28/89	Bruning	353	122	_____
	G	4,940,331	07/10/90	Wyeth et al.	356	349	_____
	H	5,025,445	06/18/91	Anderson et al.	372	20	_____
	I	5,095,492	03/10/92	Sandstrom	372	102	_____
	J	5,128,601	07/07/92	Orbach et al.	372	30	_____
	K	5,371,587	12/06/94	de Groot et al.	356	349	_____
	L	5,373,515	12/13/94	Wakabayashi, et al.	372	20	_____
	M	5,420,877	05/30/95	Sandstrom	372	34	_____
	N	5,440,578	8/8/95	Sandstrom	372	59	_____
	O	5,450,207	09/12/95	Fomenkov	356	416	_____
	P	5,524,144	06/04/96	Suzuki	359	176	_____
	Q	5,691,989	11/25/97	Rakuljic	372	20	_____
	R	5,706,301	01/06/98	Lagerström	372	32	_____
	S	5,754,571	05/19/98	Endoh et al.	372	20	_____
	T	5,852,621	12/22/98	Sandstrom	372	25	_____
	U	5,870,420	02/09/99	Webb	372	58	_____
	V	5,978,405	11/02/99	Juhász et al.	372	57	_____

Foreign Patent Documents

							Translation	
		Document	Date	Country	Class	Subclass	Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner <i>Jane Vannu</i>	Date Considered <i>8-5-05</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to

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Sheet 2 of 2

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U.S. Patent Documents								
			Date	Name	Class	Subclass	Filing Date If Appropriate	
W	5,991,324	11/23/99	Knowles et al.	372	57			
X	6,005,879	12/21/99	Sandstrom et al.	372	25			
Y	6,128,323	10/03/00	Myers et al.	372	38			
Z	6,263,002	7/17/01	Hsu, et al.	372	6			
AA	6,348,357	2/19/02	Sano	438	16			
Foreign Patent Documents								
			Date	Country	Class	Subclass	Translation	
							Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
BB	Ishihara, T., et al., "Advanced Krypton Fluoride Excimer Laser for Microlithography," SPIE Vol. 1674, Optical/Laser Microlithography V (1992) pp. 473-485							
Examiner <u>James V. Hume</u> Date Considered <u>8-5-05</u>								
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